Docket No.: 51876P351

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

HYUN-JIN CHUNG

Application No.:

Filed:

For: CAPACITOR HAVING OXYGEN

DIFFUSION BARRIER AND METHOD

FOR FABRICATING THE SAME

Art Group:

Examiner:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted concurrently with the Utility Application. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

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The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Please charge any fees due to Deposit Account 02-2666. A duplicate copy of the Fee Transmittal (PTO/SB/17) is enclosed for this purpose.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

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Substitute for form 1449A/PTO				Complete if Known		
INFORMATION DISCLOSURE				Application Number		
				Filing Date		
STATEMENT BY APPLICANT (use as many sheets as necessary)			CANT	First Named Inventor	HYUN-JIN CHUNG	
				Art Unit		
			,,	Examiner Name		
Sheet	1	of	1	Attorney Docket Number	51876P351	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number - Kind Code ² (if known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US-6,355,519	03-12-2002	Lee		
		US-6,207,528	03-27-2001	Lee		
		US-6,475,928	11-05-2002	Berenguer et al.		
		US-6,458,645	10-01-2002	DeBoer et al.		
		US-6,207,561	03-27-2001	Hwang et al.		
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	FOREIGN PATENT DOCUMENTS					
	Cite	Foreign Patent Document	Publication Date MM-DD-YYYY		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
	No.¹	Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)		Name of Patentee or Applicant of Cited Document		
		JP 2002-110910	04-12-2002	Toshiba Corp.	Abstract	
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Examiner	Date	
Signature	Considered	

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.